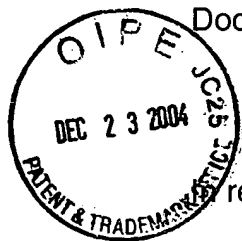


SPW

Docket No. 12054-0018



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:

Murakami et al.

Serial No.: 10/601,576

Examiner: Stephen Stein

Filing Date: June 24, 2003

Art Unit: 1775

For: Silicon Single Crystal Wafer for Particle Monitor

AMENDMENT

Commissioner of Patents
PO Box 1450
Alexandria, VA 22303

Sir:

In response to the Office Action dated September 30, 2004, please amend the application as follows: